

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/665,064	YEN ET AL.	
Examiner	Art Unit	
Rick K. Chang	3729	

	SEARCHED					
Class	Subclass	Date	Examiner			
29	739,740,8 32,281.1	11/30/2005	RC			
901	40					
294	64.1,2					

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
					
					

SEAR((INCLUDING SE	CH NOTES EARCH STRATEGY)
	DATE	EXMR
east search	12/1/2005	RC
•		